## **AMENDMENTS TO THE CLAIMS**

- 1. (Currently amended) A process for the selective removal of sulphur compounds from synthesis gas containing at least 5% carbon monoxide, at least 5% hydrogen, [[and]] at least 0.5% carbon dioxide and optionally containing water in a concentration up to saturation at a pressure of at least 15 bar comprising contacting the synthesis gas at a maximum contact temperature of 100°C with an absorbent comprising Cu/ZnO compounds [[and]] which has been activated with a reducing gas.
- 2. (Currently amended) Process The process of claim 1, wherein the sulphur compounds comprise H<sub>2</sub>S and COS.
- 3. (Currently amended) Process according to The process of claim 1, wherein the synthesis gas contains H<sub>2</sub>S in an amount effective for suppression of metal dusting of metals in contact with the synthesis gas within a temperature range between 300°C to Boudouard temperature of the synthesis gas.